COREY OSES

Ph.D. Candidate in Materials Science, Duke University

PERSONAL INFORMATION

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OBJECTIVE

To obtain a graduate degree and perform research relevant to Materials Science and Engineering in order to develop my technical and managerial skills and make significant contributions to Duke University.

EDUCATION

2013-Present **Duke University**

Doctor of Philosophy

GPA: 3.7/4.0 · Department: Mechanical Engineering and Materials Science Thesis: Advanced Techniques in High-Throughput Computational Materials Science Advisor: Stefano Curtarolo

2009-2013 Cornell University

Bachelor of Science

GPA: 3.3/4.0 · Department: Applied and Engineering Physics

Thesis: Pulsed Laser Deposition Simulation

Advisor: Joel Brock

2005-2009 Bloomfield High School

High School Diploma GPA: 3.9/4.0 · Graduated fifth in class of 428

RESEARCH

Fall.

2015-2018 Advanced Techniques in High-Throughput

Computational Materials Science

Duke University

Advisor: Stefano Curtarolo

2012-Spring 2013

Pulsed Laser Deposition Simulation

Cornell University

Developed a robust, three-dimensional Monte-Carlo simulation of the Pulsed Laser Deposition material growth technique used at the Cornell High Energy

Synchrotron Source. Advisor: Joel Brock

Synchrotron Radiation Focusing Optics — Summer 2012

Capillary Beam Stop Design

Cornell High Energy Synchrotron Source

Designed and implemented a beam stop assembly to eliminate parasitic X-Ray beams and improve focusing capabilities of the ellipsoidal glass capillary optic.

Advisors: Ernest Fontes & Rong Huang

PUBLICATIONS

January 2013 **Publication Title**

Full Journal Name

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neque ligula. Pellentesque sed quam eu felis iaculis iaculis ac a leo. Suspendisse neque neque, placerat id adipiscing et, elementum eu sem. Authors: John Sмітн, James Sмітн

October 9, 2016